



JAPANESE
INDUSTRIAL
STANDARD

Translated and Published by
Japanese Standards Association

JIS B 7271 : 2019

Portable microbe imaging scope

ICS 17.180.30

Reference number : JIS B 7271 : 2019 (E)

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Date of Establishment: 2019-03-20

Date of Public Notice in Official Gazette: 2019-03-20

Investigated by: Japanese Industrial Standards Committee
Standards Board for ISO area
Technical Committee on Machine Elements

JIS B 7271 : 2019, First English edition published in 2019-10

Translated and published by: Japanese Standards Association
Mita MT Building, 3-13-12, Mita, Minato-ku, Tokyo, 108-0073 JAPAN

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Printed in Japan

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Foreword

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